PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Daniel Stearns et al. Attorney Docket: CIL-10843

Serial No. : 09/896,722 Art Unit: 1765

Filed : June 29, 2001 Examiner: R. Kunemund

For : A Method To Repair Localized Amplitude

Defects In A EUV Lithography Mask Blank

FEE AUTHORIZATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

- Transmitted herewith is an Information Disclosure Statement in the aboveidentified case.
- The fee for the Information Disclosure Statement is \$180.
- The Commissioner is hereby authorized to charge any fees which may be required or credit any overpayment to Deposit Account 501913. A duplicate copy of this sheet is enclosed.

John P. Wooldridge Attorney for Applicants

John P. Wooldridge

Registration No.: 38,725

Date: March 9, 2005

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